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June 21, 2007

TOWNSEND and TOWNSEND and CREW LLP

By: Cindy A. Morton

PATENT

Attorney Docket No.: 16869P-041800US

Client Ref. No.: 210100244US1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

AKIRA HAMAMATSU et al.

Application No.: 10/082,593

Filed: February 22, 2002

For: SEMICONDUCTOR DEVICE
INSPECTION METHOD

Customer No.: 20350

Confirmation No. 5740

Examiner: Hoa B. Trinh

Art Unit: 2814

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed March 21, 2007, please enter the following amendments and remarks:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.